



#13
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q63075

Kazunobu FUJIKAWA, et al.

Appln. No.: 09/763,194

Group Art Unit: 1725

Confirmation No.: 3832

Examiner: Maria Alexandra ELVE

Filed: February 20, 2001

For: METHOD AND APPARATUS FOR SURFACE DISCHARGE PROCESSING, AND AN
ELECTRODE FOR SURFACE DISCHARGE PROCESSING

THIRD REQUEST FOR CORRECTED OFFICIAL FILING RECEIPT

Commissioner for Patents
Office of Initial Patent Examination
Customer Service Center
Washington, D.C. 20231

Sir:

We enclose a copy of the Corrected Official Filing Receipt for the above-identified
application and request the following corrections:


Domestic Priority data as claimed by application: delete "THIS APPLICATION IS
A 371 OF PCT/JP99/02379 05/07/1999" and **insert** "THIS APPLICATION IS A CON OF
PCT/JP99/02379 05/07/1999"

Verification for the requested correction is indicated on the original Declaration and
Transmittal Letter filed February 20, 2002.

SUGHRUE MION, PLLC
2100 Pennsylvania Avenue, N.W.
Washington, D.C. 20037-3213
Telephone: (202) 293-7060
Facsimile: (202) 293-7860

Date: December 11, 2002

Respectfully submitted,


Christopher R. Lipp
Registration No. 41,157

Attorney Docket No.: Q63075

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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLAIMS	IND CLAIMS
09/763,194	02/20/2001	1725	1020	Q63075	8	13	5

CONFIRMATION NO. 3832

CORRECTED FILING RECEIPT



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Sughrue Mion Zinn
Macpeak & Seas
2100 Pennsylvania Avenue NW
Washington, DC 20037

Date Mailed: 02/04/2002

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Kazunobu Fujikawa, Tokyo, JAPAN;
Akihiro Goto, Tokyo, JAPAN;

Domestic Priority data as claimed by applicant

THIS APPLICATION IS A [371] OF PCT/JP99/02379 05/07/1999

CON

Foreign Applications

If Required, Foreign Filing License Granted 03/21/2001

Projected Publication Date: Not Applicable, filed prior to November 29, 2000

Non-Publication Request: No

Early Publication Request: No

Title

Method and apparatus for surface discharge processing, and an electrode for surface discharge processing

Preliminary Class

219

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Title 37, Code of Federal Regulations, 5.11 & 5.15**

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